



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Gaku MINAMIHABA, et al.

Serial No.: 09/932,943

Filed: August 21, 2001

For: SLURRY FOR CHEMICAL
MECHANICAL POLISHING AND
METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

)
)
) Group Art Unit: 2823

)
) Examiner: Lee, Hsien Ming
)
)
)
)
)
)

Commissioner for Patents
Washington, DC 20231

Sir:

TRANSMITTAL LETTER

Enclosed is a reply to the Office Action of November 8, 2002. The items checked below are appropriate:

- ☐ Applicants hereby petition for a month extension of time to respond to the above Office Action. The fee of \$ for the Extension is enclosed.

The claims are calculated below:

	Claims Remaining After Amendment		Highest Number Previously Paid	Present Extra	Rate	Additional Fee
Total	37	-	25	12	x \$ 18	\$ 216.00
Indep.	4	-	4	0	x \$ 84	0.00
<input type="checkbox"/> First Presentation of Multiple Dep. Claim(s)					+\$280	0.00
					Subtotal	\$ 216.00
					Reduction by 1/2 if small entity	- 0.00
					TOTAL	\$ 216.00

- ☒ A fee of \$216 to cover the cost of the additional claims added by this reply is enclosed.
- ☐ A fee of \$ to cover is enclosed.
- ☒ A check for \$216 to cover the above fee is enclosed.

RECEIVED
FEB 18 2003
TECHNOLOGY CENTER 2800

FINNEGAN
HENDERSON
FARABOW
GARRETT &
DUNNER LLP

1300 I Street, NW
Washington, DC 20005
202.408.4000
Fax 202.408.4400
www.finnegan.com

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Dated: February 10, 2003

By: Richard V. Burgujian Reg 24,014
for Reg. No. 31,744

FINNEGAN
HENDERSON
FARABOW
GARRETT &
DUNNER LLP

1300 I Street, NW
Washington, DC 20005
202.408.4000
Fax 202.408.4400
www.finnegan.com